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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* NO

KBD

\*\* FOREIGN APPLICATIONS \*\*\*\*\* NO

KBD

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/25/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: KBD	TX	2	21	4

## ADDRESS

23125

FREESCALE SEMICONDUCTOR, INC.

LAW DEPARTMENT

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## TITLE

Method for forming a semiconductor device having metal silicide

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
RECEIVED		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )